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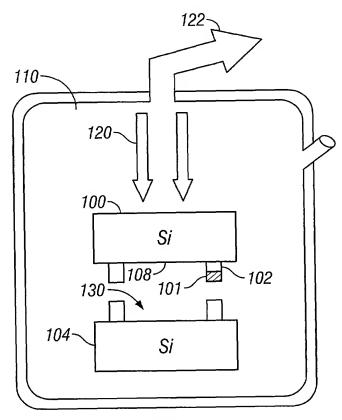
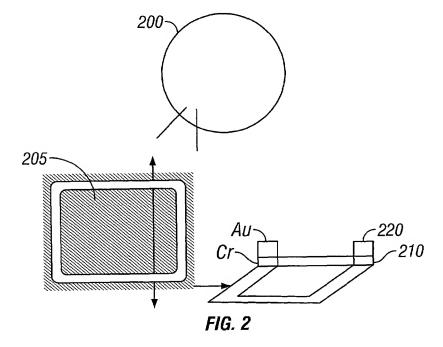


FIG. 1

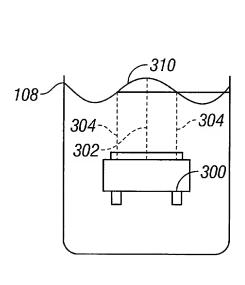




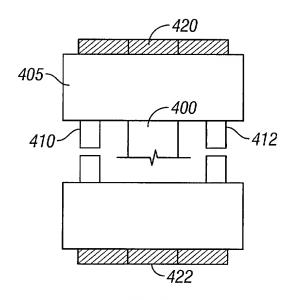
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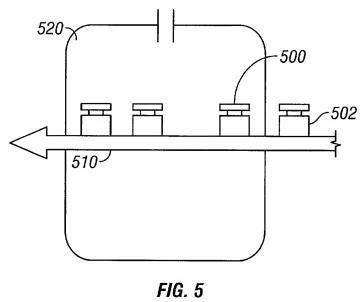






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FIG. 4

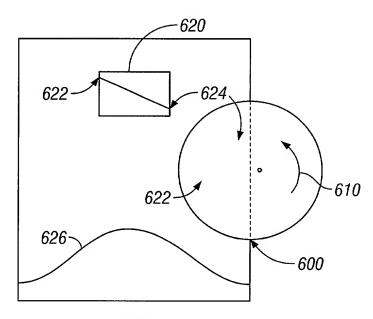




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FIG. 6

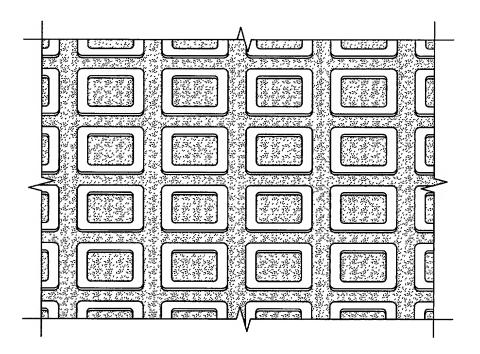


FIG. 7